

ATTORNEY DOCKET NO.: S1022/8704



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Didier DUTARTRE and Patrick JERIER

Serial No: Filed:

09/902,497 July 10, 2001

For:

METHOD OF EPITAXY ON A SILICON SUBSTRATE COMPRISING AREAS

HEAVILY DOPED WITH ARSENIC

Examiner:

Unassigned

Art Unit:

1762

## CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Box Missing Parts, Commissioner for Patents, Washington, D.C. 20231 on December 18, 2001.

**Box Missing Parts Commissioner For Patents** Washington, D.C. 20231

Sir:

## PETITION FOR TWO MONTH EXTENSION OF TIME

A two month extension of time, to and including December 21, 2001, is requested for response to the Notice to File Missing Parts mailed August 21, 2001.

A check in the amount of \$400.00 is enclosed to cover the two month extension fee. If the amount is insufficient, please charge our deposit account No. 23/2825. A duplicate of this Petition is enclosed.

Respectfully submitted,

Didier DUTARTRE and Patrick JERIER

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400.00 DP

James H. Morris Reg. No. 34,681

WOLF, GREENFIELD & SACKS, P.C.

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Attorney's Docket No.: S1022/8367

Dated: December 13, 2001

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